

09/26/03

13142 U.S. PTO

RABIN & BERDO, P.C.

Specializing in Patent, Trademark
And Copyright Law

Steven M. Rabin
Robert H. Berdo, Jr.
Phillip G. Avruch
Allen Wood

Qixia Zhang, Pat. Agent (China)

Suite 500, 1101 14th Street, N.W.
Washington, D.C. 20005
Tel.: (202) 371-8976 Fax: (202) 408-0924
E-Mail: firm@rabinchamp.com

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC

17302 U.S. PTO
10/670719

092603

September 26, 2003

Mail Stop Patent Application

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Reference: OKI 379

Re: New Patent Application of: Mitsumasa MURAISHI
Title: METHOD OF FORMING A SEMICONDUCTOR LASER CHIP
HAVING A MARKER

Sir:

Please find attached hereto an application for patent which includes:

- ☒ Specification, Claims and Abstract (13 Pages)
- ☒ 2 Sheets of Formal Drawings (Fig. 1A through Fig. 2D)
- ☒ Inventor's Declaration and Power of Attorney (3 Pages)
- ☒ Assignment document with cover page (2 Pages)
- ☒ Claim for priority
- ☒ Fee (see formula below)
- ☒ Form PTO-2038

Basic Fee \$750/375 \$ 750.00

Additional Fees:

Total number of claims: 20
in excess of 20: 0 times \$18/9 \$ 0.00

Number of independent claims: 3
in excess of 3: 0 times \$84/42 \$ 0.00

Multiple Dependent Claims \$280/140 \$ 0.00

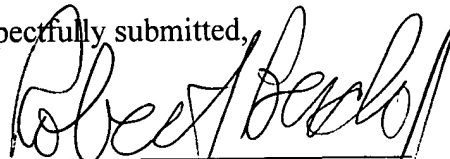
Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ 790.00

In the event there is attached hereto no check, or a check for an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of U.S. Provisional Application No. 60/413780, filed September 27, 2002.

Respectfully submitted,



Robert H. Berdo, Jr. (Reg. No. 38,075)
(Customer No. 23995)

September 26, 2003

Date

RHB:tl

FEE ENCLOSED: \$ 790.00
Please charge any further
fees to our Deposit Account
No. 18-0002